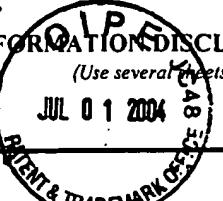


EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<p style="text-align: center;">INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)</p> <p style="text-align: center;">JUL 01 2004</p> 				Docket Number (Optional) FP03-171US	Application Number 10/752,322		
				Applicant(s) Satoru Nishide			
				Filing Date January 6, 2004	Group Art Unit --		
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>JPN</i>		5,954,528	9-1999	Ono et al.			
<i>JPN</i>		5,975,929	11-1999	Matsuura et al.			
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*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>JPN</i>		2001/0053623	12-2001	Fukamachi			
<i>JPN</i>		2002/0019160	2-2002	Takata			
<i>JPN</i>		2004/0058574	3-2004	Nishide			
<i>JPN</i>		2004/0077197	4-2004	Nishide			
FOREIGN PATENT DOCUMENTS							
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
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